

APPLICATION DATA SHEET

APPLICATION INFORMATION

Application Type:: REGULAR
Subject Matter:: UTILITY
CD-ROM or CD-R?:: NONE
Title:: METHOD AND APPARATUS FOR
FORMING SUBSTRATE FOR
SEMICONDUCTOR OR THE LIKE
Attorney Docket Number:: 245651US2
Total Drawing Sheets:: 7
Small Entity?:: NO

INVENTOR INFORMATION

Applicant Authority Type:: INVENTOR
Primary Citizenship Country:: Japan
Status:: FULL CAPACITY
Given Name:: Yoshio
Family Name:: TAKAMI
City of Residence:: Yokohama-shi
Country of Residence:: Japan
Street of Mailing Address:: c/o Advanced LCD Technologies
Development Center Co., Ltd., 292,
Yoshida-cho, Totsuka-ku
City of Mailing Address:: Yokohama-shi
State or Province of Mailing Address:: Kanagawa-ken
Country of Mailing Address:: Japan

CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 22850

REPRESENTATIVE INFORMATION

Representative Customer Number:: 22850

FOREIGN PRIORITY INFORMATION

Application Number:	Country::	Filing Date::	Priority Claimed::
2002-341330	Japan	11/25/02	YES